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Bib Data Sheet

CONFIRMATION NO. 8754

SERIAL NUMBER 10/620,379	FILING DATE 07/17/2003 RULE	CLASS 438	GROUP ART UNIT 2818	ATTORNEY DOCKET NO. 240438US2
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** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

JAPAN 2002-336669 11/20/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 10/20/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 14	TOTAL CLAIMS 18	INDEPENDENT CLAIMS 2
Verified and Acknowledged Examiner's Signature	Initials				

ADDRESS

22850
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TITLE

Semiconductor device including gate electrode for applying tensile stress to silicon substrate, and method of manufacturing the same

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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